10/28/87

DESCRIPTION TO APPEARING P

THE POLICETING CHART BROKE THE DECIS TYPE VERSOR PALLONS MITSO TAD CAUSES WHICH WERE CHAINEDS IN DERIVING THE PAILING MAYES AND EFFECTS NATURIS (PARA'S).

APPEADIT P ITEM MARKER	=	2	13	3	15	4
FALLIES MYCE / Pailure Cause	JANTE	JAMES 1M1204BA	JAMETY 1184246	JAMETU	JAMETY 114148-1	VETAGE
(a) Structural Pailure (b) Hechanical Stress	×	H	×	H	×	×
(c) Electrical Stress (d) Thermal Stress (e) Processing Anomaly				·		
ARDRY (EMD TO EMD) [a) Structural Failure Nachanical Stress Vibration	×	×	×	M	×	×
(b) Contamination (c) Electrical Stress (d) Thermal Stress (e) Processing Anguly				,		
EDERT TO BREAKINGS (GROUND) (a) Structural Failure Hechanical Stress Vibration (b) Contamination	×	×				
(c) Electrical Stress (d) Thermal Stress (e) Processing Avoraly						

TABLE 1

HYTS: RATIONALE IS PROVIDED FOR THE JAMENTANIAGES, A METALLIBRAICAL, BOND DROTH, WHICH HAS DEPONDENTED TO THE TYPICAL PART ON THE PROCESSES TO THE STATIONALE SHOULD NOT HE REPLIED TO THE JAMENVINIAGESFION BOND FORD PAILIBRE.

APPENDIX F ITEM 5 - DIODE, AXIAL LEAD JANTXVIN4148-1

RETENTION RATIONALE:

(A) DESIGN, (B) TEST, (C) INSPECTION, (D) FAILURE HISTORY.

(A) DESIGN

THE PART IS A SILICON SEMICONDUCTOR DIODE. THE SILICON CHIP IS CONNECTED TO THE PART'S EXTERNAL TERMINALS UTILIZING A METALLURGICAL BONDING PROCESS. THE SILICON SEMICONDUCTOR CHIP IS ENCAPSULATED IN A MOLDED HERMETICALLY SEALED CASE (THE PART CASE IS NONCONDUCTIVE, THUS A SHORT TO CASE IS NOT CONSIDERED AS A FAILURE MODE). THE DEVICE IS DESIGNED, QUALIFIED, TESTED AND INSPECTED TO THE REQUIREMENTS OF MIL-S-19500/116. THE PART APPLICATION IS ANALYZED TO ASSURE COMPLIANCE WITH THE 25% DERATING CRITERIA OF THE ORBITER PROJECTS PARTS LIST (OPPL). THIS ANALYSIS ASSURES PROPER ELECTRICAL AND THERMAL APPLICATION.

(B) TEST

THE PART IS SCREENED AND QUALIFIED TO THE REQUIREMENTS OF MIL-S-19500 /116. THE FULLOWING TESTS ARE PERFORMED ON SAMPLE DEVICES REMOVED FROM EACH MANUFACTURING LOT TO DEMONSTRATE QUALIFICATION OF THE LOT:

TEST / INSPECTION	C	CAUSE CONTROL						
	a	ь	c	d	e			
SOLDERABILITY RESISTANCE TO SOLVENTS THERMAL CYCLING (175 TO -65 °C) HERMETIC SEAL (1x10-8 CC/SEC) ELECTRICAL FUNCTIONAL OPERATIONAL LIFE (25 °C, 340 HR) DESTRUCTIVE PHYSICAL ANALYSIS THERMAL SHOCK (100 TO 0 °C) TERMINAL STRENGTH MOISTURE RESISTANCE EXTERNAL VISUAL SHOCK VIBRATION ACCELERATION (20,000-G) SALT ATMOSPHERE (CORROSION) OPERATIONAL LIFE FINAL ELECTRICAL FUNCTIONAL	X X X X X X X X X	X X X X	X X	X X X	X X X X X X X X X X X X X X X X X X X			

QUALIFICATION TESTS (LOT SAMPLE)

APPENDIX F ITEM 5 CONT'D

TESTS AND INSPECTIONS PERFORMED ON ALL PARTS DEMONSTRATE PROCESSES AND CONTROLS ARE ADEQUATELY PROVIDING A RELIABLE PRODUCT:

TEST / INSPECTION	C	CAUSE CONTROL						
	a	b	. c	d	e			
INTERNAL VISUAL INSPECTION HIGH TEMPERATURE LIFE THERMAL CYCLING ACCELERATION HERMETIC SEAL BURN-IN (175 °C, 96 HR) ELECTRICAL FUNCTIONAL	X X X X	x	X	X X X	X X X X X			

QUALITY CONFORMANCE TESTS (ALL PARTS)

(C) INSPECTION

THE PART HAS REQUIRED INSPECTIONS DURING MANUFACTURING PROCESS IN ACCORDANCE WITH THE REQUIREMENTS OF MIL-S-19500/116. IN ADDITION, THE PART SUPPLIER IS REQUIRED TO HAVE QUALITY CONTROL (QC) PRACTICES IN ACCORDANCE WITH THE REQUIREMENTS OF MIL-S-19500 APPENDIX D. THE REQUIREMENTS ARE TO ASSURE ADEQUATE PROCESS CONTROLS ARE IMPOSED BY THE PART SUPPLIER ON THE PARTS MANUFACTURING PROCESS. THE PROCESSES AND CONTROLS ARE ROUTINELY REVIEWED AND APPROVED BY THE QUALIFYING AGENCY (DEFENSE ELECTRONIC SUPPLY CENTER).

RECEIVING INSPECTION (FAILURE CAUSE b,c,e)

INSPECTION OF INCOMING MATERIALS, UTILITIES AND WORK-IN PROCESSES (WAFERS, PACKAGES, WIRE, WATER PURIFICATION) IS REQUIRED OF THE PART SUPPLIER.

CLEANLINESS CONTROL (FAILURE CAUSE b)

THE PART SUPPLIER IS REQUIRED TO HAVE CLEANLINESS AND ATMOSPHERE CONTROL IN CRITICAL WORK AREAS TO THE REQUIREMENTS OF FED-STD-209.

APPENDIX F ITEM 5 CONT'D

ASSEMBLY/INSTALLATION (FAILURE CAUSE a,b,e)

THE PART SUPPLIER IS REQUIRED TO HAVE INSPECTION CRITERIA, FINAL LOT DISPOSITION AND RECORDS RETENTION. THE MANUFACTURER IS ALSO REQUIRED TO SUBMIT A PROGRAM PLAN ESTABLISHING A MANUFACTURING FLOW CHART, INTERNAL AUDIT ACTIVITIES AND EXAMPLES OF DESIGN, MATERIAL EQUIPMENT STANDARDS AND PROCESS INSTRUCTIONS FOR APPROVAL BY THE QUALIFYING AGENCY. THE SUPPLIER IS ALSO REQUIRED TO PERFORM A INTERNAL VISUAL INSPECTION OF THE DEVICE PRIOR TO FINAL PART SEAL.

CRITICAL PROCESSES (FAILURE CAUSE b, e)

THE PART SUPPLIER MUST HAVE REQUIREMENTS AND CONTROLS ON MATERIALS PREPARATION (LAPPING, POLISHING, ETCHING, AND CLEANING); BONDING CRITERIA; REWORK CRITERIA; DIE ATTACHMENT AND SUPPORT; DESIGN, PROCESSING, MANUFACTURING, TESTING, AND INSPECTION DOCUMENTATION AND CHANGE CONTROL; PERSONNEL TRAINING; MASKING; PHOTORESIST REGISTRATION; OXIDATION OR PASSIVATION; METALLIZATION AND FILM DEPOSITION; SEALING PROCESSES, FAILURE / DEFECT ANALYSIS AND CORRECTIVE ACTION; AND INVENTORY CONTROL.

TESTING (FAILURE CAUSE a,c,d,e)

THE PART SUPPLIER MUST HAVE TEST EQUIPMENT MAINTENANCE AND CALIBRATION CONTROLS WHICH HAVE BEEN APPROVED BY THE QUALIFYING AGENCY. SUPPLIER MUST ALSO MAINTAIN QUALITY CONTROL INSPECTION TEST DOCUMENTATION AND FINAL LOT DISPOSITION.

HANDLING/PACKAGING (FAILURE CAUSE a)

THE DEVICES ARE PACKAGED AND HANDLED TO THE REQUIREMENTS OF MILS-19491. THE SUPPLIER IS REQUIRED TO INCLUDE TRACEABILITY (PRODUCT LOT IDENTIFICATION).

(D) FAILURE HISTORY

FAILURE MODE: SHORT, OPEN

SHUTTLE PROGRAM PART FAILURE HISTORY INDICATES NO REPORTED FAILURES FOR THIS DEVICE TYPE. A REVIEW OF GIDEF PRIOR MILITARY PART FAILURE HISTORY REVEALS NO UNCORRECTED GENERIC ISSUES EXIST.

11/02/87 (8:42pm)

APPENDIX F ITEM 5

CONT'D

PREPARED BY:

APPROVED BY:

APPROVED BY (NASA):

DESIGN

I. CHASE

RELIABILITY

M. HOVE

QUALITY

J. COURSEN